

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/544,216 Confirmation No. 9481  
 Applicant : Johan Klootwijk  
 Filed : August 1, 2005 RECEIVED  
 TC/A.U. : 2811 CENTRAL FAX CENTER  
 Examiner : Sara W. Crane DEC 07 2006  
 Docket No. : NL03 0089 US  
 Customer No. : 65913  
 Title : Trench Isolation Structure, Semiconductor Assembly Comprising such a Trench Isolation, and Method for Forming such a Trench Isolation

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

## RESPONSE &amp; AMENDMENT

Sir:

In response to the Non-Final Office action of October 4, 2006, please consider the following:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 4 of this paper.

**Amendments to the Drawings** follow after the **Remarks/Arguments** in this paper.

**Remarks/Arguments** begin on page 7 of this paper.

<b>CERTIFICATE OF MAILING or TRANSMISSION</b>	
<p>I hereby certify that this correspondence is being:</p> <p><input type="checkbox"/> deposited with the United States Postal Service with sufficient postage for first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Arlington, VA 22313".</p> <p>-OR-</p> <p><input checked="" type="checkbox"/> facsimile transmitted to the USPTO, on the date indicated below.</p>	
(Date) <u>07-DEC-2006</u>	(Signature) <u>Peter Zawilski</u> (Name) Peter Zawilski